

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TASHIRO et al.

Application No. Unassigned

Filed: March 2, 2004

Art Unit: Unassigned

Examiner: Unassigned

For: SEMICONDUCTOR LASER DEVICE
AND METHOD FOR FABRICATING THE
SAME

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

In re Appln. of TASHIRO et al.
Application No. Unassigned

TITLE AMENDMENTS:

Replace the title with:

METHOD OF FABRICATING SEMICONDUCTOR LASER